

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants	Ishiduka, et al.	Examiner:	Johnson, Connie P.
Application No.:	10/591,718	Group Art Unit:	1795
Confirmation No:	3280	Docket:	1608-7 PCT/US/RCE
Filed:	September 5, 2006	Dated:	January 28, 2010
For:	POSITIVE-TYPE RESIST COMPOSITION FOR LIQUID IMMERSION LITHOGRAPHY AND METHOD FOR FORMING RESIST PATTERN		

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Certificate of EFS-Web Transmission**

I hereby certify that this correspondence is being transmitted to the U.S. Patent and Trademark Office via the Office's electronic filing system.

Dated: January 28, 2010

Signature: K.J. Goodhand/



**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Sir:

In fulfillment of the requirements of candor and good faith set forth in 37 C.F.R. §1.56, Applicants submit herewith the following Supplemental Information Disclosure Statement in accordance with the provisions of 37 C.F.R. §1.97 and §1.98. It is understood that the information provided herein is solely for the purpose of fulfilling Applicants' obligations under the law and should not be construed as, nor is it intended to be, an admission of prior art.

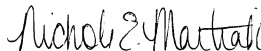
Attached hereto is Form PTO/SB/08a listing references which may be considered material in evaluating the patentability of the claims of the above-identified application. A copy of the foreign reference is enclosed herewith.

The item of information contained on the attached PTO/SB/08a was first cited in communication (Office Action) from a foreign patent office in a counterpart Japanese patent (application number 2004-170424) not more than three months prior to the filing of this Information Disclosure Statement.

No fees are deemed due with regard to this Information Disclosure Statement. However, the Commissioner is hereby authorized to charge payment of any fees associated with this communication, or credit any overpayment, to Deposit Account No. 08-2461. Such authorization includes authorization to charge fees for extensions of time, if any, under 37 C.F.R. § 1.17 and also should be treated as a constructive petition for an extension of time in this reply or any future reply pursuant to 37 C.F.R. § 1.136.

If the Examiner has any questions or comments relating to the present application, he or she is respectfully invited to contact the undersigned at the telephone number set forth below.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Nichole E. Martiak".

Nichole E. Martiak  
Registration No. 55,832  
Attorney for Applicants

HOFFMANN & BARON, LLP  
6900 Jericho Turnpike  
Syosset, New York 11791  
(973) 331-1700